



Patent Application No. 10/613,989

Applicant: YAMASAKI et al.

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Examiner: L. Larson

Docket No.: 402698

Customer No.: 23548

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

### **REPLY TO OFFICE ACTION**

Sir:

In reply to the Office Action dated September 27, 2005, Applicants petition for a one-month extension of time, submit the requisite fee therefor, and request that the referenced patent application be amended as shown below.

**Amendments to the Title** are on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

01/30/2006 HALI11 00000068 121216 10613989  
01 FC:1251 120.00 DA

*AMENDMENTS TO THE TITLE*

Replace the title with:

~~LEAD~~METHOD OF FORMING FOR LEADS OF  
A SEMICONDUCTOR DEVICE